

03500.017969

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applic	ation of:	)
	SU IWATA, et al. No.: 10/805,323	Examiner: Unassigned  Group Art Unit: 1753
Filed: Marc	·	; )
MI MA PH	NC OXIDE FILM TREATMENT ETHOD AND METHOD OF ANUFACTURING OTOVOLTAIC DEVICE TILIZING THE SAME	) : ) : September 30, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **INFORMATION DISCLOSURE STATEMENT**

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are enclosed.

The listed documents are discussed at page 2, line 13, to page 3, line 1, of the subject specification.

An English-language translation of the Inoue et al. article is also enclosed.

In accordance with 37 C.F.R. § 1.97(b), since a first Office Action on the merits of the subject application has not yet been issued, neither a statement under 37 C.F.R. §1.97(e) nor payment of a fee is believed to be required for consideration of this Information Disclosure Statement. However, the Commissioner is hereby authorized to

charge any fee which may be required in connection with this paper to Deposit Account

No. 06-1205. A duplicate of this paper is enclosed for that purpose.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants Damond E. Vadnais Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

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FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)		ATTY DOCKET NO. 03500.017969		PLICATION NO. 10/805,323		
		APPLICANT  Masumitsu IWATA, et al.				
(Use several sheets if necessary)  September 30, 2004		FILING DATE March 22, 2004		GROUP 1753		
		TO MON E	U.S. PATENT DOCUMENTS			-
*EXAMINER INITIAL	DOCUMENT \	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		TRACESSE				
	_					
		FC	DREIGN PATENT DOCUMENTS			
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
				10		
		OTHER DOCUMENT(S	s) (Including Author, Title, Date, Pertinent Pages, Etc.)			
Y. Inoue et al., "Optical Confinement Effect in a-SiGe Solar Cells on Stainless Steel Substrates", 29p-MF-2, 51st Applied Physics Society Scientific Lecture Meeting, Lecture Drafts, Autumn 1990, p. 747. (English-language translation attached)						
H. Sannoniya et al., "a-SiC/a-Si/a-SiGe Multi-Bandgap Stacked Solar Cells with Bandgap Profiling", Technical Digest of the International PVSEC-5, Kyoto, Japan, 1990, pp. 387-390.						
EXAMINER	EXAMINER DATE CONSIDERED					

Sheet	<u> </u>	of .	1

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.